



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/624,340  
Confirmation No. .... 6987  
Filing Date .... July 21, 2003  
Inventor ..... Brent A. McClure  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2831  
Examiner ..... N. Ha  
Attorney's Docket No. .... MI22-2067  
Customer No. .... 021567  
Title: Capacitor Constructions and Methods of Forming

**INFORMATION DISCLOSURE STATEMENT**

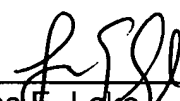
**References – See Attached Form PTO-1449**

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449. Pursuant to 37 C.F.R. §1.98(a)(2)(1) no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art references, if any, are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: 09 Mar 2005

By:   
James E. Lake  
Reg. No. 44,854

Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
MI22-2067SERIAL NO.  
10/624,340LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)APPLICANT  
Brent A. McClure et alFILING DATE  
July 21, 2003GROUP  
2831

## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	2002/0142488	10/02	Hong, Suk-Kyoung			
	AB	6,403,156	06/02	Jang			
	AC	6,746,930	6/04	Yang			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

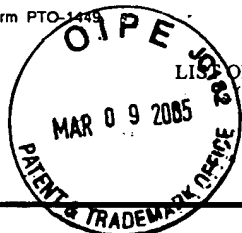
	AR		Ritala et al, "Perfectly Conformal TiN and Al2O3 Films Deposited by Atomic Layer Deposition," Chemical Vapor Deposition, v. 5, No. 1, 1999, p. 7-9.
	AS		

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	09/653,156		Agarwal (as amended 12/2004)			
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	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

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